UNIVERSITY OF MICHIGAN

COLLEGE OF ENGINEERING
THE RADIATION LABORATORY
DEPARTMENT OF ELECTRICAL ENGINEERING
AND COMPUTER SCIENCE

3228 EECS BUILDING
1301 BEAL AVENUE
ANN ARBOR, MICHIGAN 48109-2122
734 764-0500   FAX 734 647-2106
http://www.eecs.umich.edu/RADLAB/

July 24, 2008

Re: Certification for Pressure Pro Receiver
Model/PN(s): RMD4R
FCC ID: RMD4R
IC: 4785A-4R

STATEMENT OF MODIFICATIONS

There were no modifications made to the DUT by this test laboratory. (Also see Section 3.1 of the attached Test Report).

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Valdis V. Liepa
Research Scientist

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GENERAL PRODUCT INFORMATION

The device, for which certification is pursued, has been designed by:

Advantage Pressure Pro, LLC
205 West Wall St.
Harrisonville, Missouri 64701
Contact: Phillip Zaroor
pzaroor@advantagepressurepro.com
Tel: 816 887 3505
Fax: 517 492-1904

It will be manufactured by:

Lectronix, Inc.
5858 Enterprise Drive
Lansing, MI 48911
Contact: Daryl Chymyck
Phone: 517-492-1926
Fax: 517-492-1904

Canadian Contact:

Advantage PressurePro
20 Alma St. South
Guelph, Ontario, N1H 5W5
Contact: Doug McMeen
dmcmeen@advantagepressurepro.com
Tel: 816 887-3505
Fax:517 492-1904

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POWER OF ATTORNEY

A letter granting Valdis V. Liepa the Power of Attorney is on file and can be provided when so requested.